Electronic Supporting Information

Direct Growth of Doping Controlled Monolayer WSe₂ by

Selenium-Phosphorus Substitution

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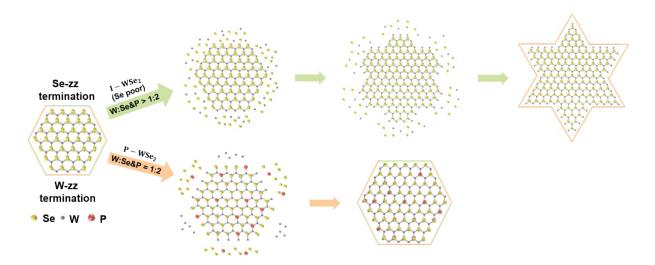


Figure S1. Schematic illustration of the domain shape changes and their comparison between intrinsic and P-doped WSe₂. Schematic ball-and-stick models for the different shapes of the monolayer WSe₂ structure. The initial crystal structure on the left shows two types (W or Se) of WSe₂ terminations. The schematic diagram on the right illustrates the domain shape changing procedure depending on the W:Se&P rates of the two different terminations.

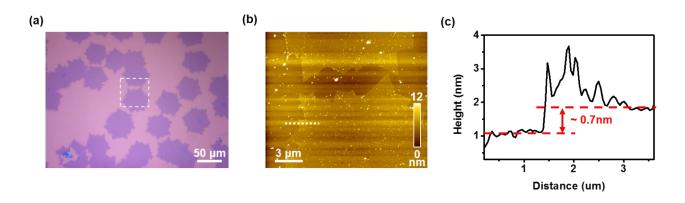


Figure S2. AFM images of P-doped WSe₂ layers. (a) Optical image of CVD grown P-doped WSe₂ layers. (b) AFM image of the dotted area in (a). Height profile of a WSe₂ layer taken across the dotted line in (b), which indicates the monolayer thickness.

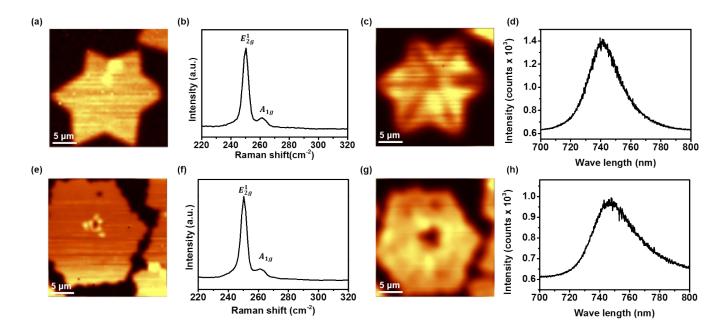


Figure S3. Raman and photoluminescence spectra of other intrinsic and p-doped WSe₂ flakes. (a) Scanning Raman intensity at the E¹_{2g} peak of intrinsic WSe₂. (b) Raman spectrum of intrinsic WSe₂. (c) Scanning photoluminescence of intrinsic WSe₂. (d) Photoluminescence spectrum of intrinsic WSe₂. (e) Scanning Raman intensity at the E¹_{2g} peak of P-doped WSe₂. (f) Raman spectrum of P-doped WSe₂. (g) Scanning photoluminescence of P-doped WSe₂. (h) Photoluminescence spectrum of P-doped WSe₂. Scale bars are 5μm.

Supporting information 1: 2D carrier concentration calculation

The 2D carrier concentration in an p-type semiconductor is derived from the drift current density (J)^{1,2} equation:

$$J = qn\mu_n E + qp\mu_p E = \sigma E$$
 (Equation 1)

Where, q is the electron charge, E is the electron field, n is electron concentration, p is hole concentration, μ_n is electron mobility, μ_p is hole mobility, and σ is conductivity respectively.

P-doped WSe₂ is p-type semiconductor materials with hole majority carrier (equal to 2D carrier concentration, n_{2d}), electron minority carrier can be neglected and the supplementary equation 1 becomes:

$$J = q n_{2d} \mu_p E \qquad \text{(Equation 2)}$$

Carrier concentration can be calculated by:

$$n_{2d} = \frac{J}{q\mu_p E} = \frac{\sigma}{q\mu_p}$$
 (Equation 3)

To calculate the conductivity, we use the following equation:

$$\sigma = \frac{I_{ds} L}{V_{ds}W}$$
 (Equation 4)

Where, I_{ds} is the drain current, V_{ds} is the drain voltage, L, and W are the channel length and channel width, respectively.

To calculate the hole mobility, we use the following equation:

$$\mu_p = \frac{G_m L}{C_i V_{ds} W}$$
 (Equation 5)

Where, G_m and C_i are transconductance and capacitance per unit area, respectively.

Using above conductivity and hole mobility equation, the equation 3 becomes:

$$n_{2d} = \frac{I_{ds} \quad L}{q\mu_p V_{ds} W} = \frac{I_{ds} C_i}{qG_m}$$
 (Equation 6)

Based on the conductivity-voltage characteristic in Figure 7b, we extract the doping concentrations.

References

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